

Notice of References Cited	Application/Control No. 10/710,950		Applicant(s)/Patent Under Reexamination LAI ET AL.	
	Examiner VAN T. PHAM		Art Unit 2627	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,229,773	05-2001	Chou, Wen-Te	369/44.28
*	B	US-6,167,011	12-2000	Sun et al.	369/44.41
*	C	US-6,317,399	11-2001	Ohtani et al.	369/47.44
*	D	US-6,469,962	10-2002	Chu, Meng-Huang	369/44.28
*	E	US-2004/0136282	07-2004	Chen, Chih-Yuan	369/044.35
*	F	US-2001/0014062	08-2001	Roh, Seung-Jin	369/44.28
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.